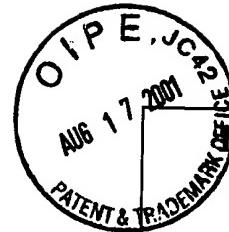


INFORMATION DISCLOSURE CITATION		Atty. Docket No.: 55436USA6A.002		Serial No.: 09/519,448			
		Applicant(s): DAVID et al.					
		Filing Date: March 5, 2000		Group: 1744			
U.S. PATENT DOCUMENTS							
Examiner Initials		Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate
<i>(Large grid area for U.S. Patent Documents)</i>							
<i>RECEIVED</i> <i>MAR 20 2001</i> <i>TC 1700</i>							
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	SubClass	Translation Yes No
<i>JX</i>		EP 0 856 592 A1	08/05/98	EPO	C23C	14/00	
<i>J</i>		WO 96/40446	12/19/96	PCT	B05D	3/02	
<i>J</i>		WO 97/40207	10/30/97	PCT	C23C	16/30	
<i>J</i>		WO 97/48836	12/24/97	PCT	C23C	16/26	
<i>J</i>		WO 99/29477	06/17/99	PCT	B26B	21/54	
OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)							
<i>JX</i>		David et al., "Plasma Deposition and Etching of Diamond-Like Carbon Films", <i>AIChE Journal</i> , Vol. 37, No. 3, pp. 367-376, March 1991					
<i>J</i>		Bray et al., "New family of tailorabile thin-film coatings", <i>Advanced Materials & Processes</i> , 146, No. 6, pp. 31-34, December 1994					
EXAMINER				Date Considered			
<i>Alexander</i>				<i>1/10/02</i>			

***Examiner:** Initial if reference considered; whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.



INFORMATION DISCLOSURE STATEMENT	Atty. Docket No.: 55436 USA 6A	Serial No.: 09/519,448
	Confirmation No.: Unknown	
	Applicant(s): DAVID et al.	
	Filing Date: 5 March 2000	Group: 1744

U.S. PATENT DOCUMENTS

Examiner Initial	Document Number	Date	Name	Class	SubClass	Filing Date If Appropriate
J	4,812,344	03/14/89	Jaeger et al.			<i>RECEIVED JUL 10 2002 PTO</i>
J	5,788,766	08/04/98	Yamamoto et al.			
V	5,938,679	08/17/99	Freeman et al.			

FOREIGN PATENT DOCUMENTS

	Document Number	Date	Country	Class	SubClass	Translation	
						Yes	No
J	JP 0 211 4 650	04/26/90	Japan (English Language Abstract Only)				
	JP 0 511 0 163	04/03/93	Japan (English Language Abstract Only)				
	WO 94/21372	09/29/94	PCT				
	WO 98/21626	05/22/98	PCT				

OTHER DOCUMENTS (Including Authors, Title, Date, Pertinent Papers, etc.)

L	C. F. M. Borges, "A Novel Technique for Diamond Film Deposition Using Surface Wave Discharges," <i>Diamond and Related Materials</i> , Vol. 4, pp. 149-154 (1995).
J	IBM Technical Disclosure Bulletin, "Magnetostrictive Molecule Separator Chromatography," US, IBM Corp., New York, Vol. 37, No. 8, pp. 527-528 (August 1994).

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1/10/02

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